

**PATENT**  
**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In Re Application of:

Ming-Fang Wang

Serial No.: 10/677,158

Filed: October 1, 2003

Confirmation Number: 8159

Group Art Unit: 1765

Examiner: George, Patricia Ann

TKHR No. 252016-3330

Top Team No. 0503-A30328US

**For: HIGH-K GATE DIELECTRIC STACK  
PLASMA TREATMENT TO ADJUST  
THRESHOLD VOLTAGE CHARACTERISTICS**

**RESPONSE TO OFFICE ACTION**

Mail Stop: Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

The Office Action mailed March 20, 2007, has been carefully considered. In response thereto, please consider the following remarks.